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Substitute for form 1449A/PTO

ATTORNEY'S DKT No.  
015290-592APPLICATION NO.  
10/075,602INFORMATION DISCLOSURE  
STATEMENT BY APPLICANTAPPLICANT  
Jeffrey HUNG et al.FILING DATE  
February 15, 2002GROUP  
1765

## U.S. PATENT DOCUMENTS

Examiner Initials	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication (MM-DD-YYYY)
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	Number	Kind Code (if known)			Yes	no
L.J.M.-E	EP 0407169	—	Europe	01-09-1991		
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231.

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Substitute for form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>	ATTORNEY'S DKT No. 015290-592	APPLICATION No. 10/075,602
	APPLICANT Jeffrey HUNG et al.	
	FILING DATE February 15, 2002	GROUP 1765

NON PATENT LITERATURE DOCUMENTS		
Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
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Examiner Signature	Lynette T. Umeg - Ewing	Date Considered 6/14/2002

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